

Support information

Synergistic passivation with multi-dentate 2,6-pyridinedicarboxylic acid for high-performance perovskite solar cells

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From the EIS data and the following equation, the defect state density of the device at different energies can be quantified:

$$C = -\frac{1}{\omega Z''}$$

$$N_t(E_\omega) = -\frac{V_{bi}}{eW} \frac{dC}{d\omega} \frac{\omega}{K_B T}$$

$$E_\omega = K_B T \ln\left(\frac{\omega_0}{\omega}\right)$$

Where C is the capacitance of the device, ω is the angular frequency, Z'' is the imaginary part of the impedance, N_t is the trap density, W is the depletion layer width, q is the elementary charge, K_B is the Boltzmann constant, T is the absolute temperature, ω_0 is the escape frequency ($\approx 10^{11} \text{ s}^{-1}$), and E_ω is the energy boundary.

The defect density of states (N_t) can be calculated by using the following formula:

$$N_t = 2\varepsilon_r\varepsilon_0 V_{TFL}/eL^2$$

Where V_{TFL} is the defect filling limiting voltage, ε_0 is the vacuum dielectric constant ($8.854 \times 10^{-14} \text{ F/cm}$), ε_r is the relative dielectric constant of MAPbI₃ (21.2), q is electron charge ($1.6 \times 10^{-19} \text{ C}$), and L is the thickness of perovskite film (about 353 nm). V_{TFL} can be found from the SCLC curve, and N_t can be calculated.

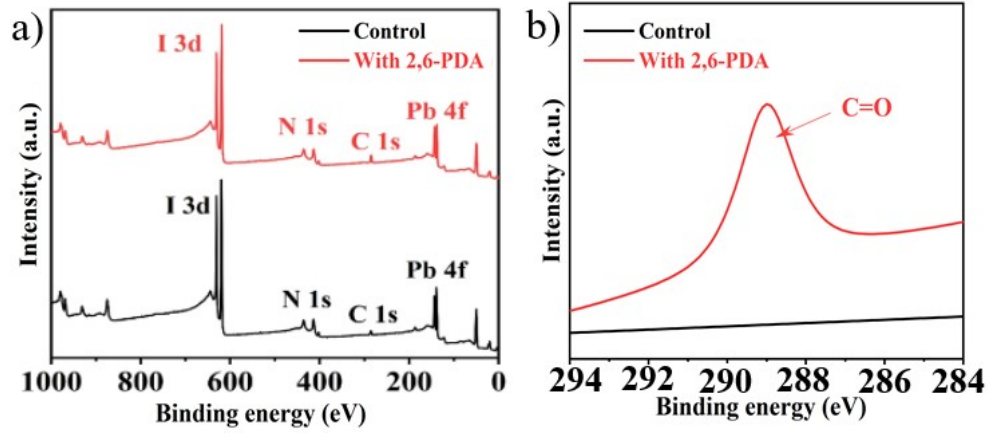


Fig. S1. a) XPS spectra of ITO/PTAA/MAPbI₃ and ITO/PTAA/MAPbI₃/2,6-PDA films. b) XPS C = O spectra of ITO/PTAA/MAPbI₃ and ITO/PTAA/MAPbI₃/2,6-PDA films.

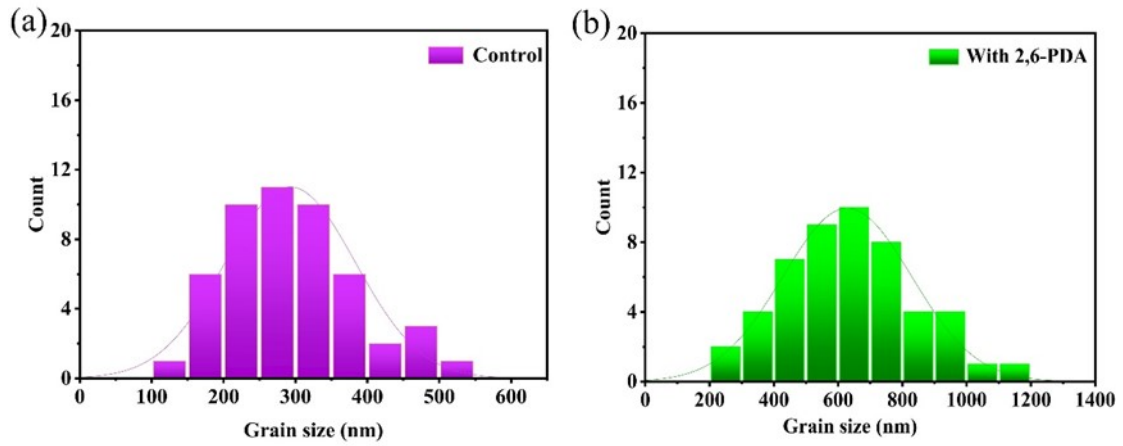


Fig. S2. The grain sizes of (a) ITO/PTAA/MAPbI₃ and (b) ITO/PTAA/MAPbI₃/2,6-PDA films.

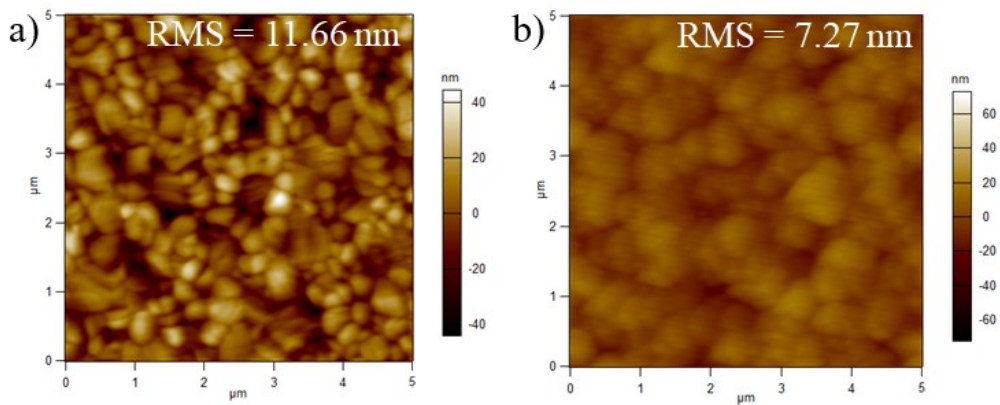


Fig. S3. The 2D AFM images of (a) ITO/PTAA/MAPbI₃ and (b) ITO/PTAA/MAPbI₃/2,6-PDA films.

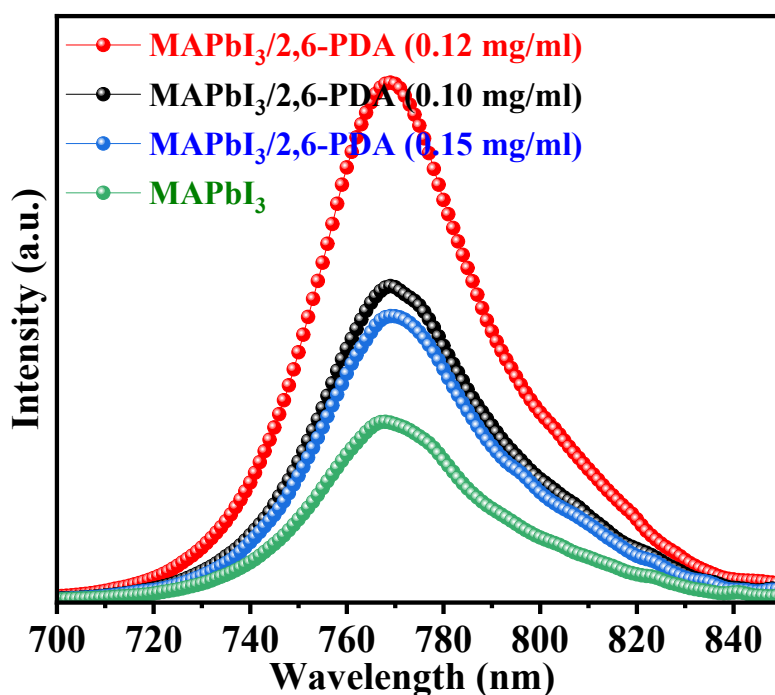


Fig. S4 The PL emission of the quartz/MAPbI₃/2,6-PDA film with the different 2,6-PDA concentration.

Table S1. Photovoltaic parameters of the device in different scanning directions

| Sample | Direction | V _{oc} (V) | J _{sc} (mA/cm ²) | FF (%) | PCE (%) | HI | Average HI |
|---------|-----------|------------------------|--|-----------|------------|------|---------------|
| 2,6-PDA | Forward | 1.10 | 23.37 | 80.26 | 20.57 | 0.17 | 0.14 |
| | Reverse | 1.11 | 23.31 | 79.24 | 20.50 | | |
| | Forward | 1.10 | 21.83 | 81.58 | 19.64 | 0.10 | |
| | Reverse | 1.11 | 21.90 | 81.38 | 19.68 | | |
| | Forward | 1.11 | 21.93 | 79.53 | 19.41 | 0.15 | |
| | Reverse | 1.11 | 21.99 | 79.45 | 19.47 | | |
| Control | Forward | 1.10 | 21.93 | 79.28 | 19.19 | 1.24 | 1.05 |
| | Reverse | 1.10 | 21.92 | 77.64 | 18.72 | | |
| | Forward | 1.09 | 21.80 | 76.51 | 18.21 | 0.84 | |
| | Reverse | 1.09 | 21.89 | 77.39 | 18.52 | | |
| | Forward | 1.09 | 21.74 | 77.58 | 18.46 | 1.07 | |
| | Reverse | 1.10 | 21.57 | 79.91 | 18.86 | | |

Table S2. TRPL fitting parameters for different films

| Sample | τ_1 (ns) | A_1 (%) | τ_2 (ns) | A_2 (%) | T_{ave} (ns) |
|----------------------------------|---------------|-----------|---------------|-----------|----------------|
| MAPbI ₃ | 6.42 | 26.67 | 16.70 | 73.33 | 15.43 |
| MAPbI ₃ /2,6-PDA | 6.74 | 23.63 | 19.69 | 76.37 | 18.45 |
| MAPbI ₃ /PCBM | 1.61 | 96.84 | 4.41 | 3.16 | 1.84 |
| MAPbI ₃ /2,6-PDA/PCBM | 1.20 | 98.73 | 3.59 | 1.27 | 1.29 |

Table S3. EIS fitting parameters of control device and 2,6-PDA device

| Sample | R_s | $R_{rec}(\Omega)$ | CPE1 | $R_{dr}(\Omega)$ | CPE2 |
|---------|-------|-------------------|-----------------------|------------------|-----------------------|
| Control | 10.02 | 6870 | 4.63×10^{-9} | 23339 | 4.11×10^{-7} |
| 2,6-PDA | 12.90 | 10876 | 4.44×10^{-9} | 26402 | 7.30×10^{-7} |